

DOCKET NO.: 240882US0



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF :  
TOMOHISA KONNO ET AL : EXAMINER: RACHUBA, MAURINA T.  
SERIAL NO.: 10/626,521 :  
FILED: JULY 25, 2003 : GROUP ART UNIT: 3723  
FOR: AQUEOUS DISPERSION FOR :  
CHEMICAL MECHANICAL POLISHING :  
AND PRODUCTION PROCESS OF :  
SEMICONDUCTOR DEVICE :

AMENDMENT

COMMISSIONER FOR PATENTS  
ALEXANDRIA, VIRGINIA 22313

SIR:

In response to the Office Action dated November 13, 2006, please amend the above-identified application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 7 of this paper.